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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10031842	FILING DATE 06/10/2002	CLASS 216	SUBCLASS 63	GAU 1746	EXAMINER <i>Utah Ahmed</i>
**APPLICANTS: Becker Volker; Laermer Franz; Schilp Andrea;					
**CONTINUING DATA VERIFIED: THIS APPLICATION IS A 371 OF PCT/DE00/01836 06/06/2000 <i>SA</i>					
** FOREIGN APPLICATIONS VERIFIED: GERMANY 199 33 841.8 07/20/1999 <i>SA</i>					
PG-PUB <input type="checkbox"/> DO NOT PUBLISH <input type="checkbox"/>			RESCIND <input type="checkbox"/>		
Foreign priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no Verified and Acknowledged Examiners's initials <i>SA</i>			ATTORNEY DOCKET NO 10191/2169		
TITLE : Device and method for etching a substrate using an inductively coupled plasma U.S. DEPT. OF COMM./PAT. & TM. PTO-436L (Rev. 12-94)					

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Assistant Examiner	Total Claims <input type="text"/> Print Claim for O.G. <input type="text"/>
ISSUE FEE		Primary Examiner	DRAWING
Amount Due <input type="text"/>	Date Paid <input type="text"/>		Sheets Drwg. <input type="text"/> Figs. Drwg. <input type="text"/> Print Fig. <input type="text"/>
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	Applicati n Examiner <input type="text"/>
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